PAUS O 7 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIMOTO et al

Serial No.: 08/897,839

Serial No.: 08/897,839

Filed: July 21, 1997

For: STRESS-ADJUSTED INSULATING
FILM FORMING METHOD,
SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING THE
SAME

SAME

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time period for filing a response to the office action of April 7, 2003, initially set to expire July 7, 2003, be extended one month up to and including August 7, 2003. The requisite \$110.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to Deposit Account No. 12-2174.

Respectfully submitted

08/08/2003 CNGUYEN 00000053 08897839

01 FC:1251

110.00 OP

Date: August 7, 2003 LORUSSO, LOUD & KELLY 3137 Mount Vernon Avenue Alexandria, VA 22305

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